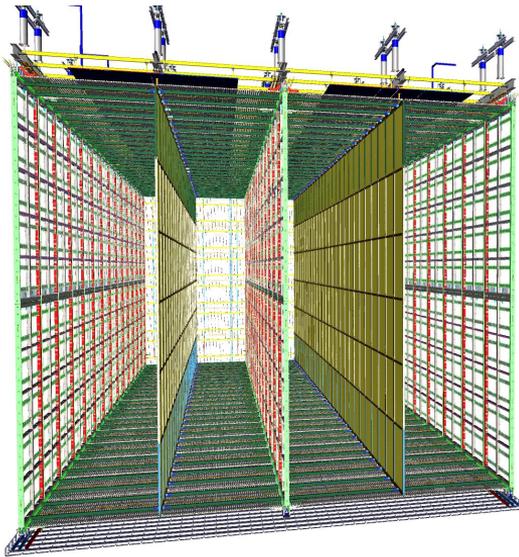


Optimization of the X-Arapuca Photon Collector for the DUNE FD1 and FD2

C.M. Cattadori - INFN Milano Bicocca
on Behalf of the DUNE Collaboration





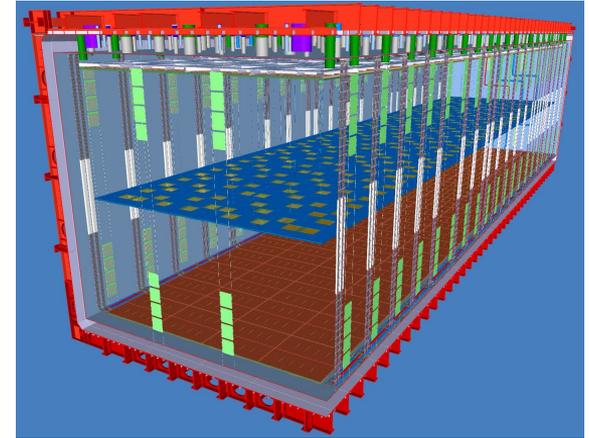
FD1

The DUNE PDS

LY requirement to boost the trigger (p-decay) and energy resolution (SN ν) capabilities of the DUNE PDS::

- $LY_{\min} > 0.5 \text{ PE/MeV}$
- $LY_{\text{ave}} > 20 \text{ PE/MeV}$
- **PDE of XA: 2%-3%**
- $S/N > 4$
- $\text{DCR}/\text{ch} < 1 \text{ kHz}$

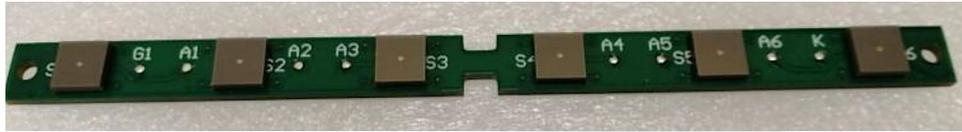
- 6000 XA devices ($48 \times 10 \text{ cm}^2$) embedded in the three Anodic Planes
- SIPM: $48 \times 6 \times 6 \text{ mm}^2$ (1.73 cm^2 or 3.9% Si coverage) ganged @ 48
- LArTPC: Horizontal Drift



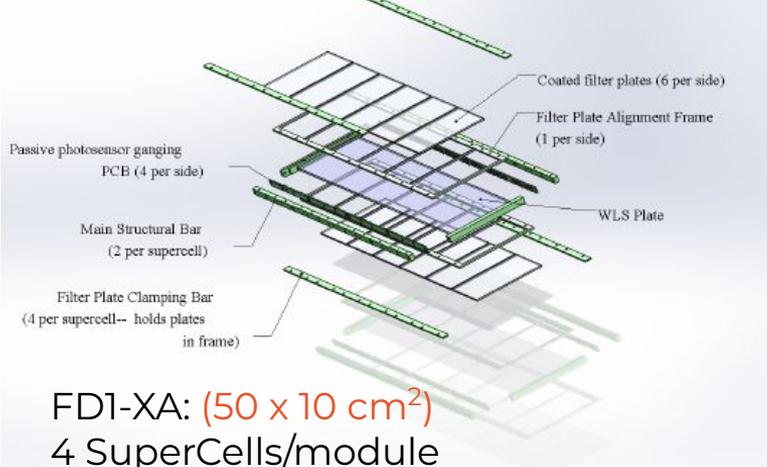
FD2

- 320 XA devices ($58 \times 58 \text{ cm}^2$) on the cathode (320kV) \rightarrow PoF bias/readout
- 320 XA devices on the membrane
- SIPM: $160 \times 6 \times 6 \text{ mm}^2$ (5.8 cm^2 Si, 1.6% Si coverage) ganged @80
- LArTPC: Vertical Drift Technology

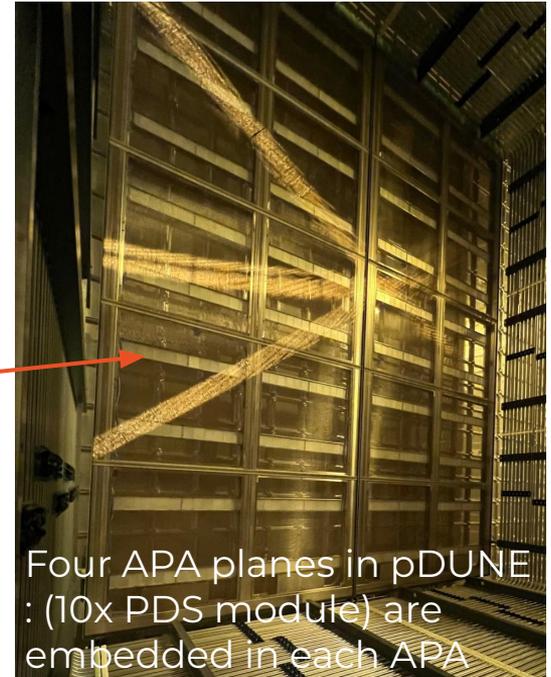
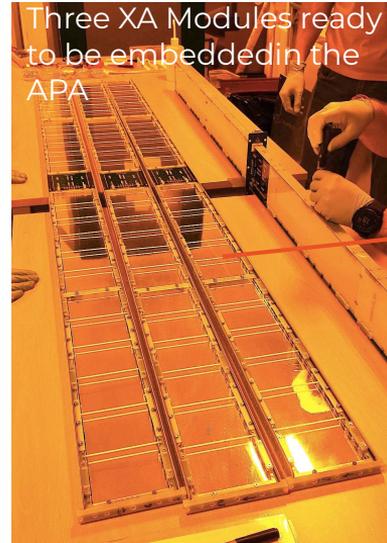
The FD1 PDS & X-Arapuca device



Th SiPM board with 6 SiPM: rigid G10

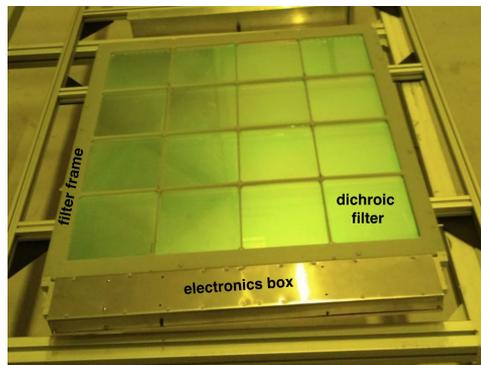


- FD1-XA: (50 x 10 cm²)
- 4 SuperCells/module
- 10 module/APA
- 1500 Total Modules
- 1000 Double sided 500 single sided



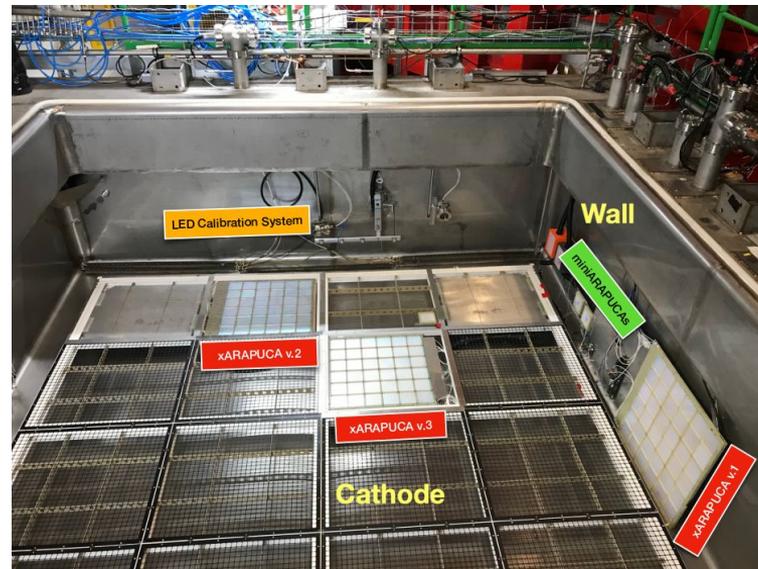
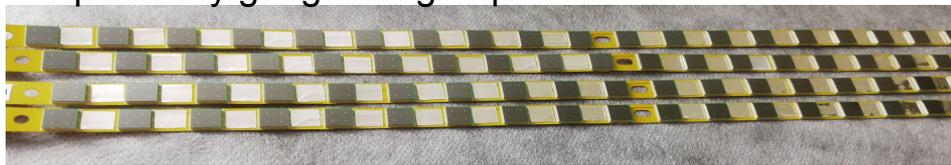
The FD2 PDS & X-Arapuca device

	WLS dimples	DF size (mm ²)	DF	SiPM	PoF	SoF	shared elec. box
M1		100x200	ZAOT	HPK			x
M2		100x200	ZAOT	HPK			x
M3	x	100x200	ZAOT	HPK			x
M4	x	100x200	ZAOT	HPK			x
M5	x	150x150	PE	FBK		x	
M6	x	150x150	PE	HPK			
M7	x	150x150	PE	HPK			
M8	x	150x150	PE	FBK			
C1		100x200	ZAOT	HPK	x	x	
C2		100x200	ZAOT	HPK	x	x	
C3		150x150	PE	FBK	x	x	
C4	x	150x150	PE	HPK	x	x	
C5	x	150x150	ZAOT	HPK	x	x	
C6	x	150x150	ZAOT	HPK	x	x	
C7	x	150x150	ZAOT	FBK	x	x	
C8	x	150x150	ZAOT	HPK	x	x	



In pDUNE-FD2 8 Memb-XA +8 cath.-XA + (6 optimized) deployed in 2023

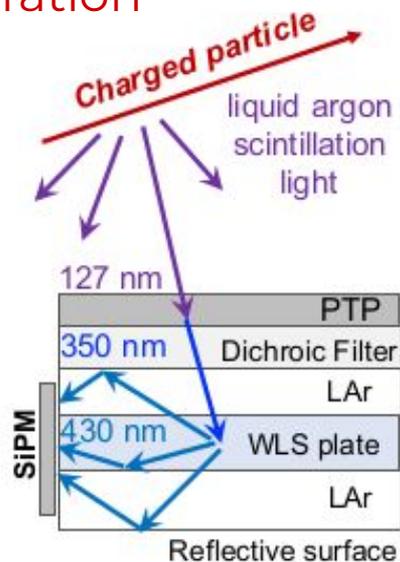
4 (of 8) flex circuits with 20 SiPMs passively ganged at groups of 5



2 x Cath-XA & 1 x memb-XA in the CERN Coldbox

Optimization (and measurements) of the XA PDE

- Developed **methods and setup** to accurately **measure the absolute PDE of the XA device** and
- Developed accurate **simulation** of the photon transport in the device
- Improved the **XA components quality and configuration**
 - ✓ **WLS-LG plate** (FD1 & FD2)
 - High grade PMMA embedding WLS-dye* showed superior performances of the BL PVT product**.
 - Tailored WLS-dye concentration and thickness vs. plate size.
 - ✓ **WLS-LG Optical sealing** (both FD1 & FD2)
 - Enhanced light trapping in the WLS
 - ✓ **SiPM to WLS-LG coupling** (both FD1 & FD2)
 - ✓ **Dichroic Filters** (only FD2)

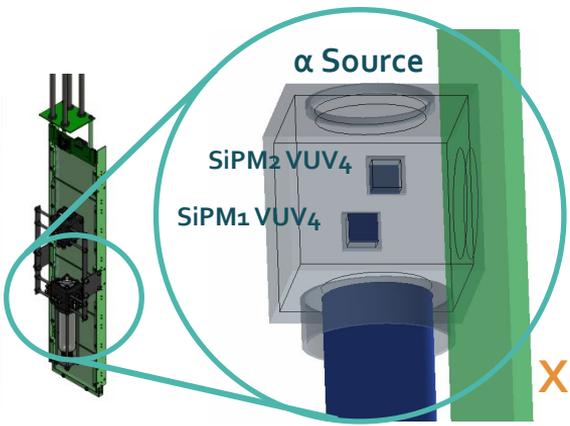
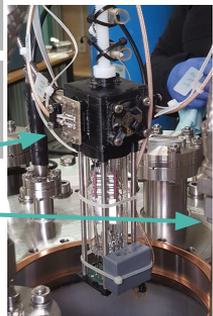
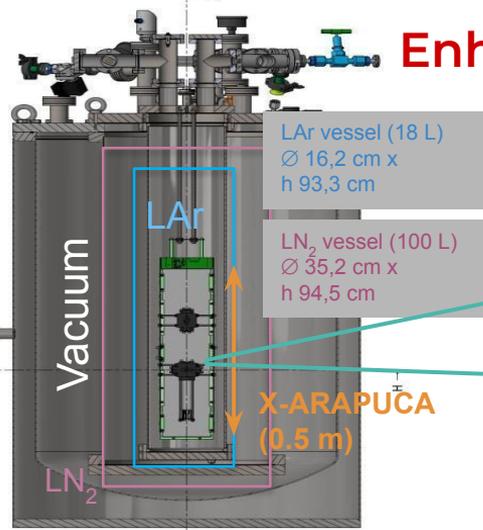


Enhancement of the BL FDI-XA PDE

CIEMAT results

Lidine 2022- update 2023

2 VUV sensitive SiPMs are symmetrically placed with respect to the X-ARAPUCA and alpha source (²⁴¹Am)



$$\epsilon_{XA} (\%) = \frac{PE_{mm^2}(XA)}{PE_{mm^2}(Ref. SiPM)} \cdot f_{corr} \cdot \epsilon(Ref. SiPMs)$$

$$\epsilon_{XA} (\%) = 100 \cdot \frac{PE(XA)}{\gamma_{expected}} \cdot f'_{corr}$$

$\epsilon_{XA} (\%)$ - DIRECT MEASUREMENT
(VUV₄ Comparison)

$\epsilon_{XA} (\%)$ - CROSSCHECK
(From known LY and MonteCarlo)

$\epsilon(Ref. SiPMs) = 11.3\%$

PDE 40%
PDE 45%
PDE 50%

	FBK+EJ	HPK +EJ	HPK +G2P
PDE 40%	1.41 ± 0.11	1.56 ± 0.12	2.12 ± 0.16
PDE 45%	1.63 ± 0.12	1.78 ± 0.14	2.38 ± 0.18
PDE 50%	2.01 ± 0.15	1.93 ± 0.15	2.58 ± 0.20

	FBK+EJ	HPK +EJ	HPK +G2P
PDE 40%	1.34 ± 0.10	1.51 ± 0.12	2.02 ± 0.17
PDE 45%	1.56 ± 0.12	1.72 ± 0.14	2.28 ± 0.19
PDE 50%	1.93 ± 0.15	1.87 ± 0.15	2.51 ± 0.21

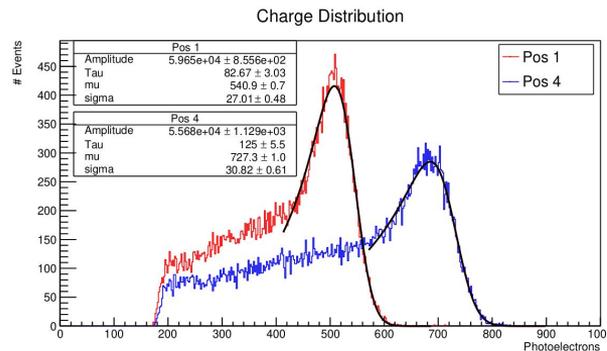
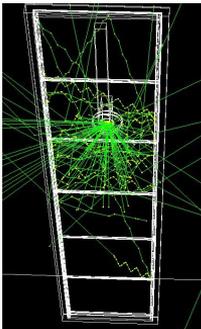
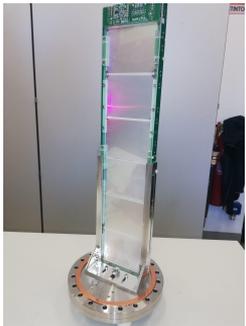
High grade PMMA embedding WLS-dye.

+30%



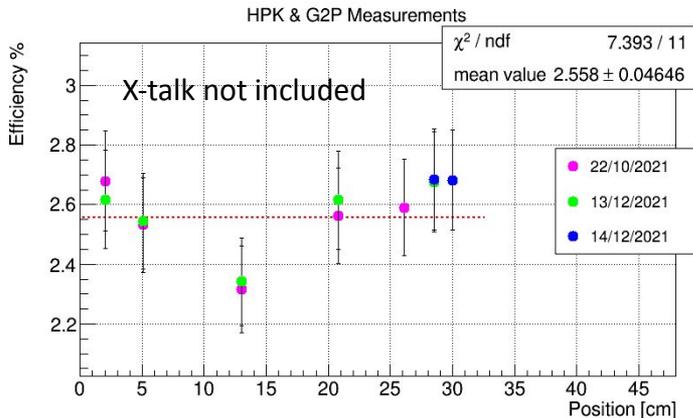
Enhancement of the BL FDI-XA PDE : INFN-MiB

update 2023



Method: z-scanning of the whole cell (~ 2 Sr) with an ^{241}Am exposed α source [\(JINST 16 \(2021\)09027\)](#)

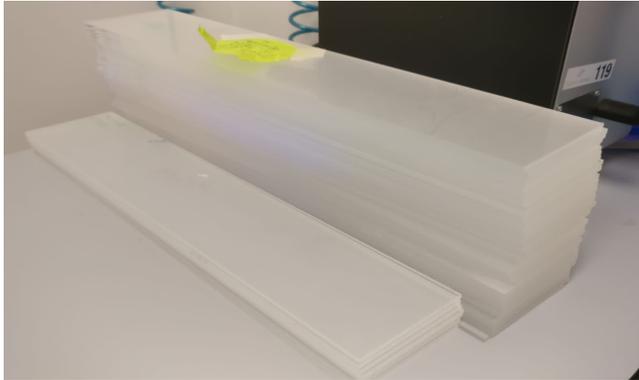
$$\epsilon = \frac{4\pi \cdot \alpha \text{ peak(ADC)}}{\text{s.p.h.e.(ADC)} \cdot f_{int} \cdot LY_{LAr} \cdot En_{\alpha} \cdot q_{\alpha} \cdot \Omega}$$



No correction for LAr purity applied.
Expected: < 8%

	SiPM PDE	XA PDE MiB Xtalk corr.	XA PDE CIEMAT Xtalk corr.
HPK & G2P	50%	2.49 (0.15)	2.51 (0.21)
FBK & G2P	45%	2.1 (0.23)	1.87 (0.15)
FBK & Eljen	45%	1.8 (0.18)	1.56 (0.12)

G2P WLS: Production for pDUNE FD1 & FD2



Glass-to-Power Co. <https://www.glasstopower.com/> is now the BL manufacturer and DUNE industrial partner.

Showed R&D and mass production capabilities



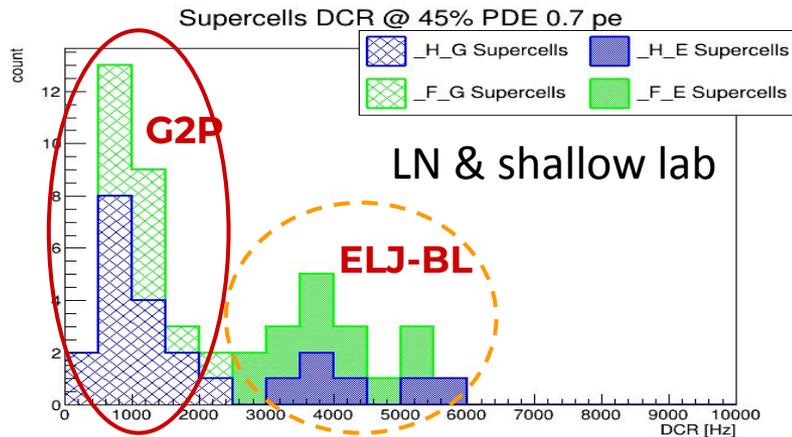
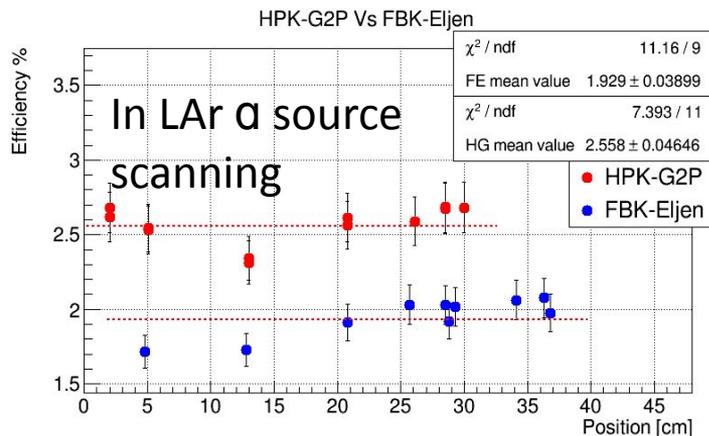
- **80 x WLS slabs for FD1-pDUNE:**
 $48.0 \times 9.3 \times 0.38 \text{ cm}^3$

Validated Casting, Laser cut and edge polishing procedures of the WLS from the as-casted plates..

- **16 (M0)+ 6 (M1) WLS slabs for pDUNE-FD2:**
 $60.7 \times 60.7 \times (0.38 \text{ \& } 0.55) \text{ cm}^3$

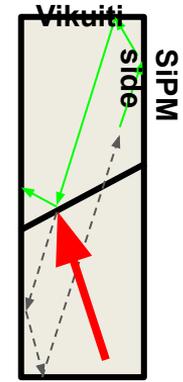
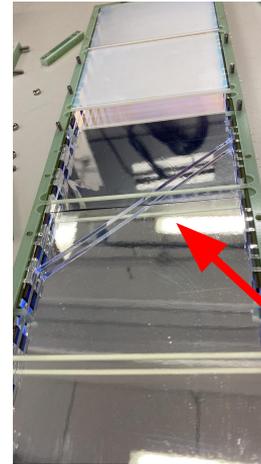
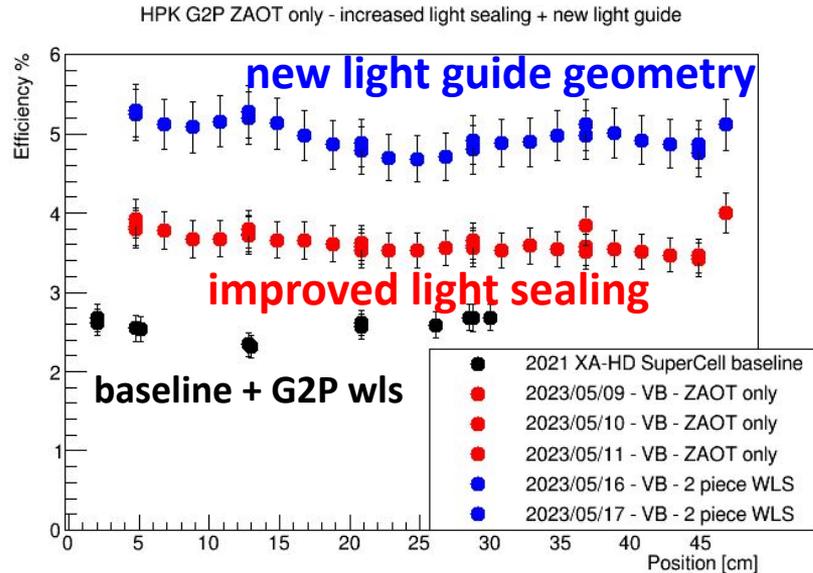
G2P-WLS features & Performances

- **Superior Cryoresilience:** No cracks or failures in cooling/warming cycle at rate of 3-4 mm/sec of the 80 x FD1 pDUNE & 16 x FD2 Module-0 plates
- Superior light guiding surfaces as casted
- Superior LY and DCR of XA cells with PMMA vs PVT (BL) WLS

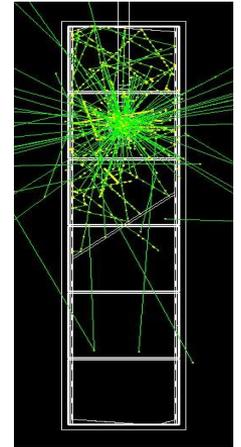


FD1: Modified WLS-LG geometry

Major improvement of the FD1 XA PDE cutting the WLS-LG in two parts by a 40° cut and improved LG light-sealing optimization via optical sims measurements with MiB setup



40° cut in the middle with Vikuiti applied



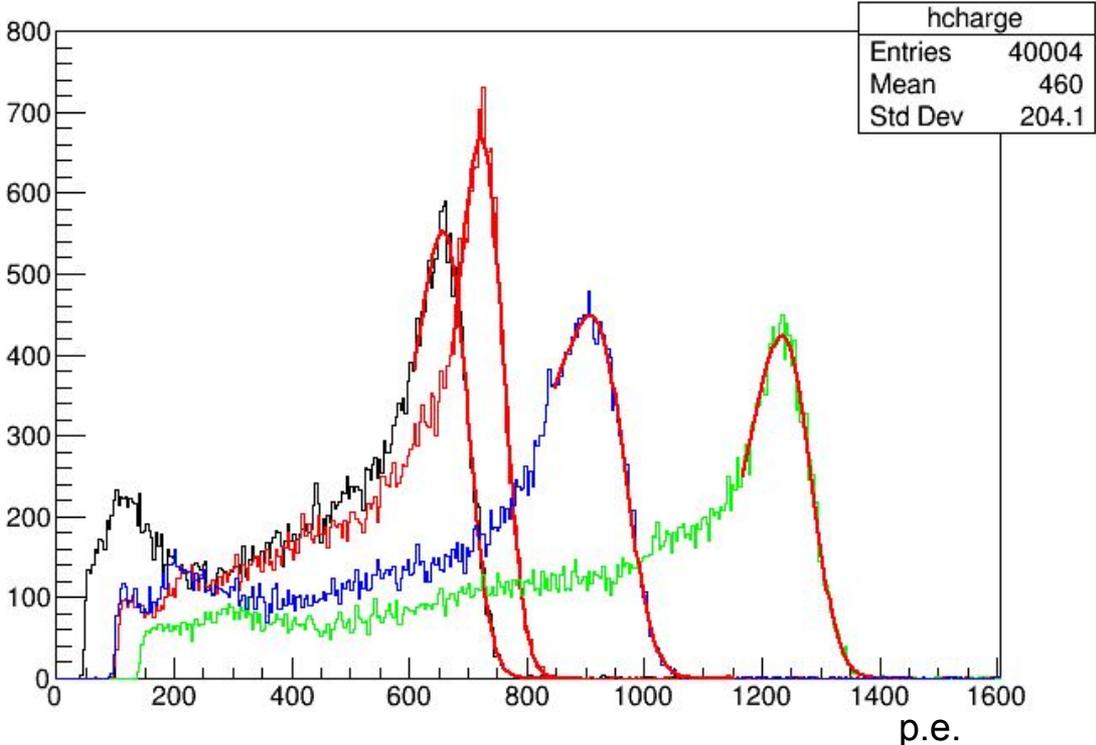


Alpha Spectra resolution, p.e. calibrated

- baseline
- p-DUNE WLS, NO G10 blocks, ZAOT
- p-DUNE WLS, G10 blocks, ZAOT
- WLS with cut, G10 blocks, ZAOT

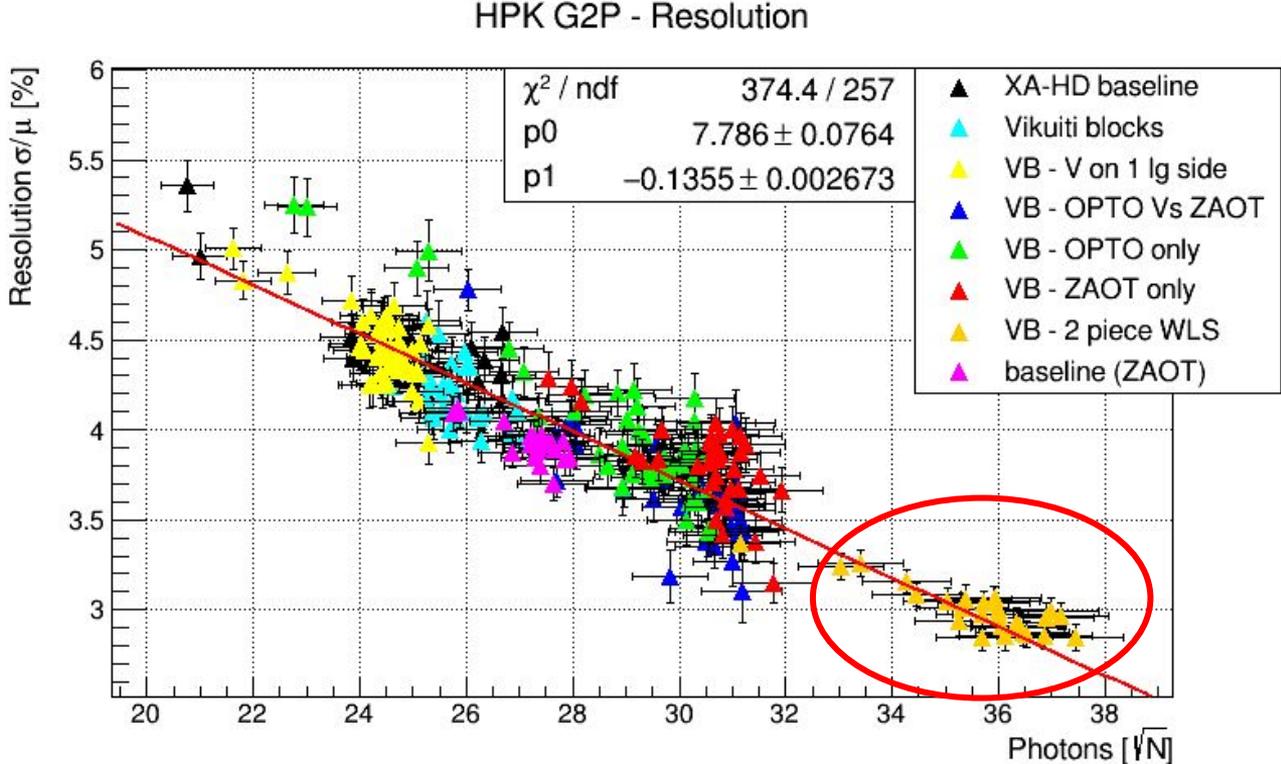
All taken in the middle of the 3rd dichroic filter

mu = 692.704 **sigma = 31.4929**
mu = 749.976 **sigma = 30.3693**
mu = 962.185 **sigma = 38.2959**
mu = 1272.26 **sigma = 38.0256**



Alpha Spectra resolution

- The 2 pieces WLS Ig improves the energy resolution w.r.t. all the other configurations



WLS-LG: Attenuation length (λ_{att})

- Both the Absorbance of the pTP photons & the λ_{att} of the photons emitted by the secondary WLS depends on the WLS chromophore concentration
 - The chromophore concentration & WLS-LG thickness are tuned to maximize the Photon Collection Efficiency (PCE)
- λ_{att} (400-500 nm) is the leading parameter for high PCE.
 - **Required: $\lambda_{att} > \text{Optical Path}$**

$$A = \log_{10}(1/T)$$

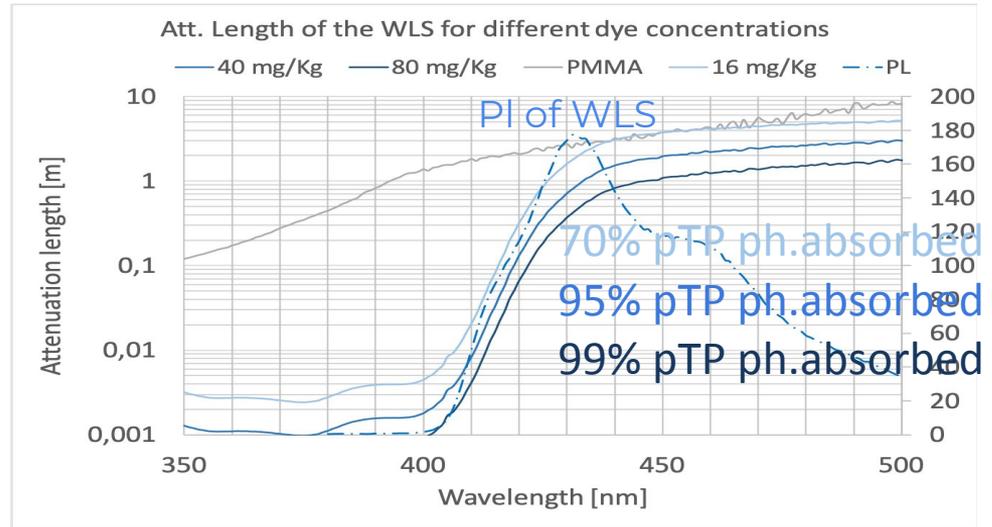
$$T = I/I_0 \exp(-d/\lambda_{att})$$

$$A = \epsilon c d$$

ϵ = molar extinction coeff.

c = concentration

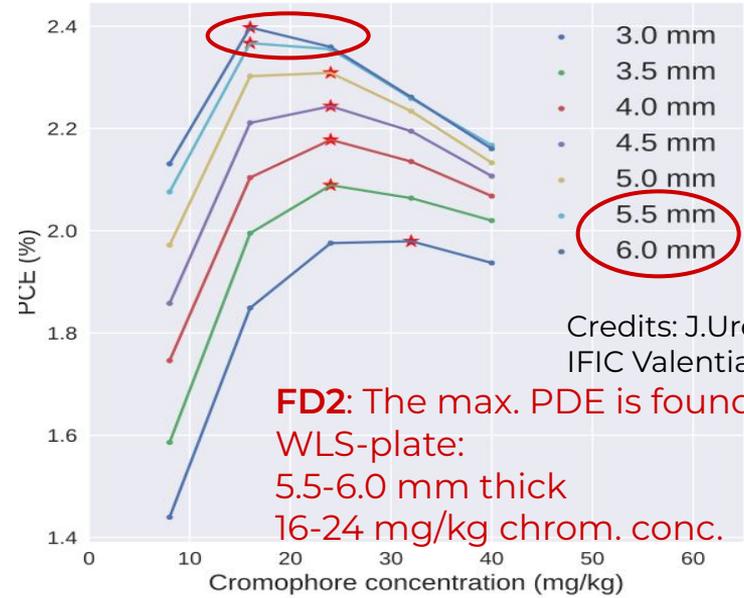
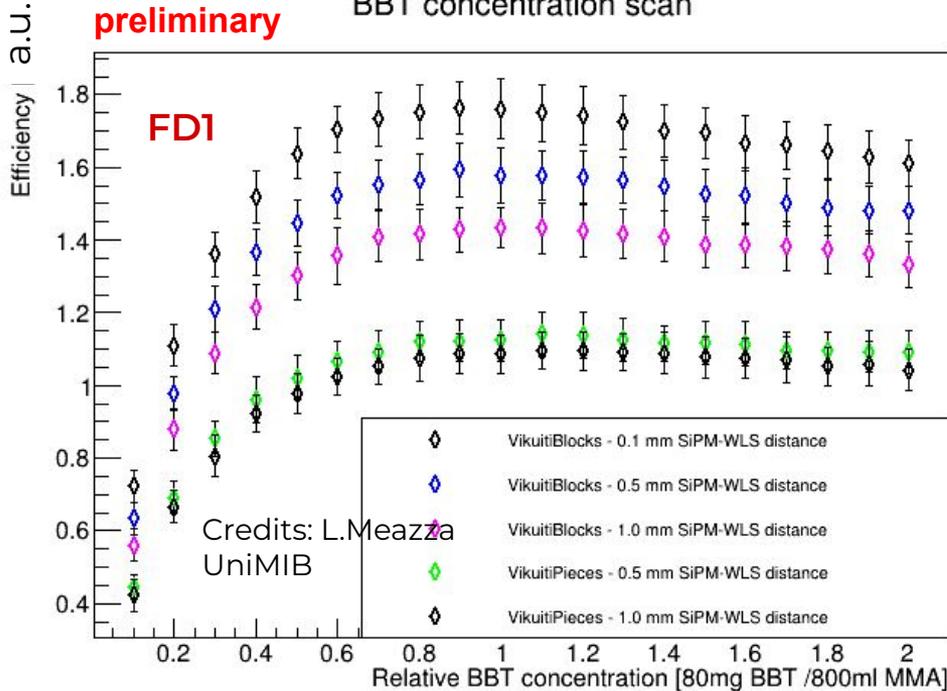
d = optical path



WLS- LG: chromophore concentration and thickness optimization for FD1 and FD2

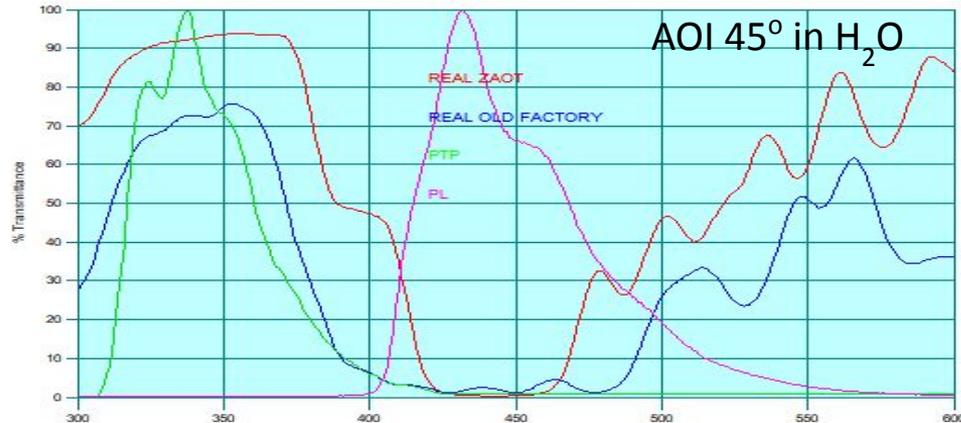
OP ~ 10-100 cm; $\lambda_{att}^{opt} = 37$ cm; thick=3.8mm
 BBT concentration scan

OP ~ 60-200 cm; $\lambda_{att}^{opt} \sim 200$ cm; thick = 5.5 mm



Dichroic Filter Optimization for the FD2 Module-0

- Found two new vendors for FD2 production
- DF Designed to operate in LAr (@45°), pass 300-400 nm & reflect 400-500 nm
- **Pro:** Improved transmittance in the pTP emission range
- **Pro:** Improved reflectivity in the WLS-LG emission range
- **Cons:** Narrower reflectivity window
- Size increased from 10 x 10 cm² to 15 x 15 cm² to increase XA the active surface



		Subs	Design
OPTO	FD1	B270	45° Air
ZAOT	FD2	BF33	45° LAr
Photon Export	FD2	F.silica	45° LAr

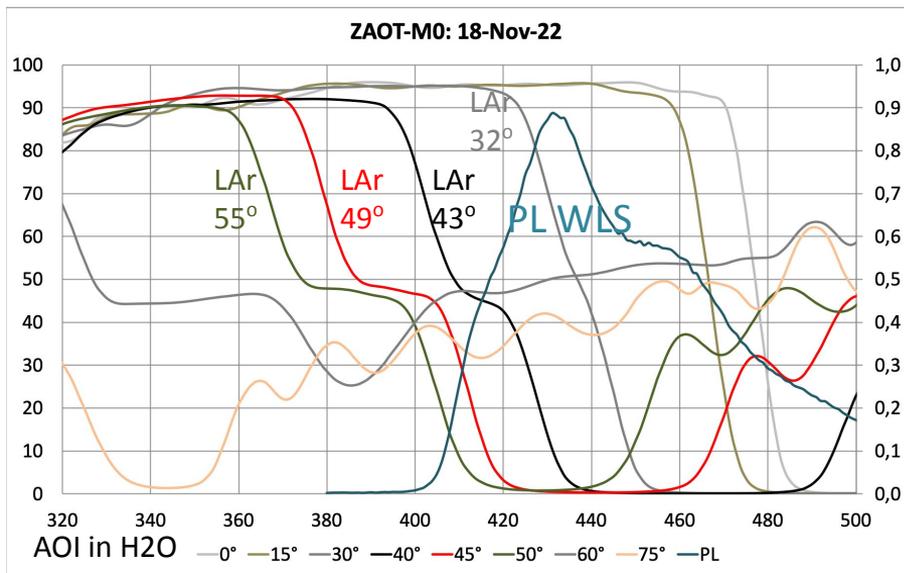
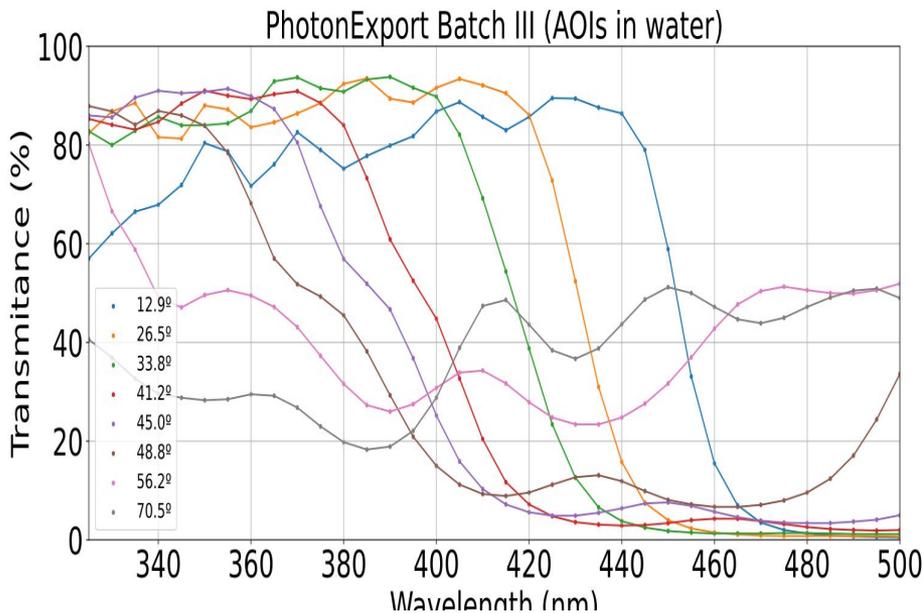
The DF T curves measured in H2O

AOI H2O-to-LAr transformed by Snell law

$$\text{Cutoff } (n) \Rightarrow \lambda = \lambda_0 \sqrt{1 - \frac{n_1^2}{n_2^2} \sin^2 \theta}$$

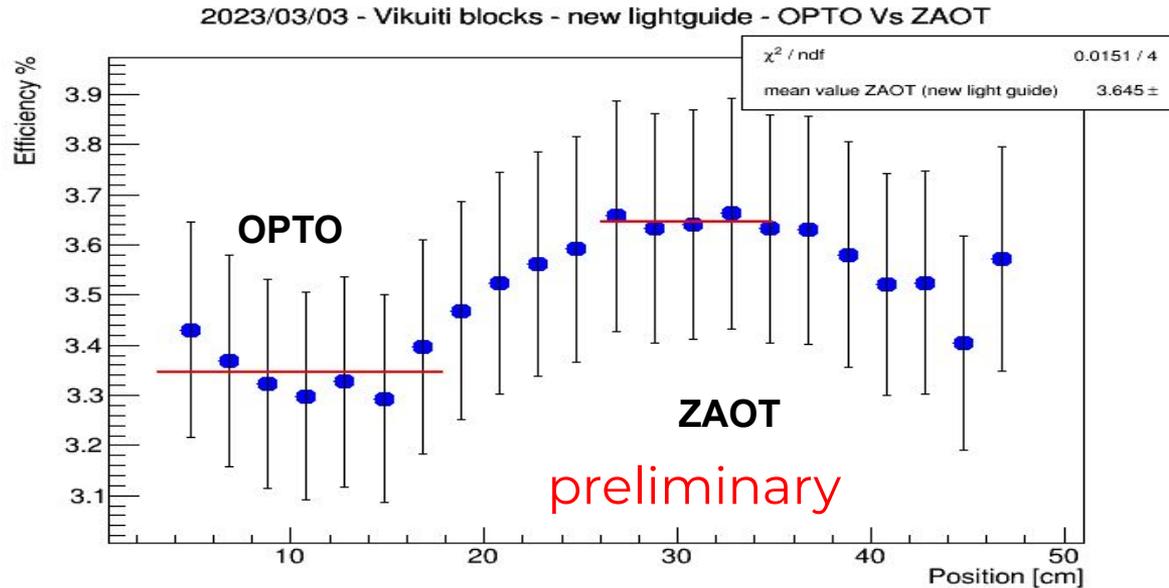
PE- DF: T Curves: 14.5 x 14.5 cm² for Module-0

ZAOT-DF: T Curves: 14.5 x 14.5 cm² for Module-0



Assessment of Module-0 DF performances in a XA in LAr

- the PDE of one FD1-XA equipped with three BL DF (OPTO), three FD2 (ZAOT) has been measured with the MiB setup in LAr
- +10% PDE well reproduced by G4 simulations

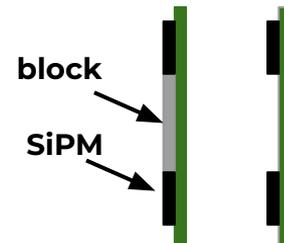


Summary

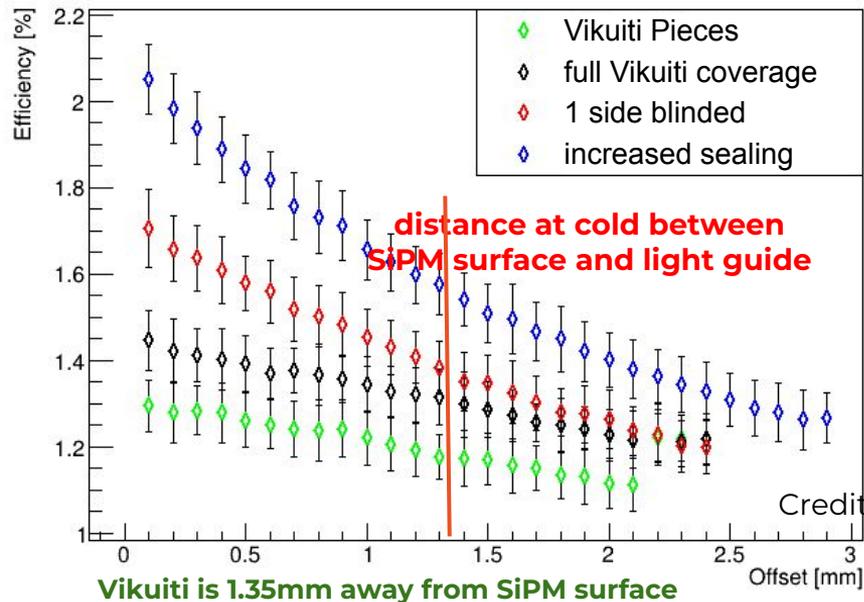
- The PDE of the DUNE PDS building block has been measured and improved
- For **The BL-FD1-XA (EJ WLS) a PDE \leq 2% was measured**
- The optimization of the FD1-XA components & relative configuration
 - ✓ **Change of the BL WLS-LG \rightarrow PDE \sim 2.5%**
 - The G2P PMMA WLS-LG is now the BL for FD1 & FD2
 - ✓ **SiPM-to-WLS-LG contact & reflectors \rightarrow PDE \sim 3.5%**
 - ✓ **WLS geometry to recover photons ineffective paths \rightarrow PDE \sim 5%**
- The **PDE of the FD2-BL XA** as deployed in the **FD2-Module0** has been measured (F.Di Capua's talk) **\sim 2% (preliminar)**
- **FD2-XA PDE optimization** is being pursued
 - ✓ Optimization of the **WLS chromophore concentration & thickness (M1)**
 - ✓ Optimization of the **Dichroic Filters (Module0 & Module1)**
 - ✓ Optimization of the **SiPM-to-WLS-LG contact**

FDI: Study of the LG-to-(SiPM & reflectors) position

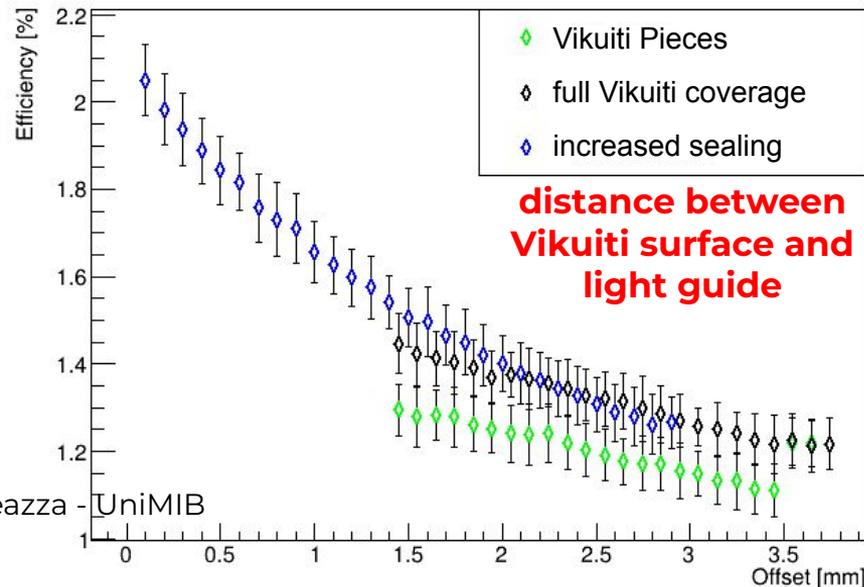
- **PDE is strongly dependent on the SiPM-LG distance and**
 - **distance of the Vikuiti reflector** seems to be the main factor
- proposed a wider (+1 mm) WLS-LG & to flush reflector to SiPMs



SiPM Offset Scan



SiPM Offset Scan



FD2: SiPM - to Lightguide coupling

FD2-XA designed with no SiPM-to-WLS-LG gap .

To follow the 1% shrink of the PMMA \rightarrow ~6 mm

- SiPMs located on flex circuits + spring loaded mount
- SiPM in dimple cuts (flat or cylindrical) machined at the edges of WLS



WLS-LG: Attenuation length (λ_{att})

For PMMA WLS-LG in LAr, the critical angle (θ_c) = 56°

- For $\theta > \theta_c$ photons get trapped and guided by LG-TIR to SiPMs.
 - $\lambda_{att} > \text{Optical Path (OP)}$
- For $\theta < \theta_c$ photons leaves the LG and are guided by DF to SiPMs.
 - Tens of reflections may happen before reaching the SiPMs: required **superior Optical Density of the DF** in the range **440-500 nm**.

